

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

patent application of

Jason M. Benz

Serial No.: 09/695,028

Group Art Unit: 1765

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Examiner: Alanko Anita Karen

METHOD FOR THIN FILM LASER REFLECTANCE CORRELATION FOR

SUBSTRATE ETCH ENDPOINT

Honorable Commissioner of Patents Alexandria, Virginia 22313-1450

SUBMISSION OF CORRECTED FORMAL DRAWINGS

Sir:

Submitted herewith are three (3) sheets of corrected formal drawings comprising figures 1A -8 for the above-identified patent application. Acknowledgment of receipt is respectfully requested. Please substitute these corrected formal drawings for the drawings which were filed with the application.

Respectfully submitted,

Piter a. Balrave

Peter A. Balnave

Registration No. 46,199

McGinn & Gibb, PLLC

Intellectual Property Law 8321 Old Courthouse Road, Suite 200 Vienna, VA 22182-3817 (703) 761-4100

Customer No. 21254